



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT
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TC 1700

In Re U.S. Patent Application

Applicants: Satoshi Komiya et al.

Serial No.: 10/049,971

Filed: October 3, 2003

For: **SILICON WAFER AND METHOD FOR
MANUFACTURE THEREOF, AND
METHOD OF EVALUATION OF
SILICON WAFER**

Examiner: Not Yet Assigned

))
) Art Unit: 1765
)
) Confirmation No.: 1669
)) *I hereby certify that this correspondence is*
) *being deposited with the United Postal*
) *Service as first class mail in an envelope*
) *addressed to: Mail Stop PATENT*
) *APPLICATION / Commissioner for Patents*
) */ P.O. Box 1450 / Alexandria, Virginia*
) *22313-1450, on January 20, 2004*
))
)
)
) Gerald T. Shekleton; Reg. No. 27,466AMENDMENT TRANSMITTALMail Stop FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an amendment in the above-identified application.

() No additional fee is required.

Fee Calculation For Claims As Amended

	As Amended		Previously Paid For		Present Extra	Rate	Additional Fee
Total Claims	41	-	20	=	21	x\$18.00=	\$ 378.00
Independent Claims	26	-	7	=	19	x\$86.00=	\$ 1,634.00
Multiple Dependent Claims						x\$____.00=	\$ _____
					Total Additional Fee		\$ 2,012.00

(x) A check in the amount of \$2,012.00 is attached.

(x) The Commissioner is hereby authorized to charge any additional fees, which may be required to this application number under 37 C.F.R. § 1.16-1.17, or credit any overpayment, to Deposit Account No. 23-0920. Should no proper amount be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 23-0920.

120 South Riverside Plaza, Suite 2200
Chicago, Illinois 60606-3913
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WELSH & KATZ, LTD.

Gerald T. Shekleton
Registration No. 27,466



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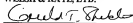
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PATENT
Atty. Docket: 90738

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Gerald T. Shekleton

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PRELIMINARY AMENDMENT

Mail Stop PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Preliminary to the examination of the above application, please amend as follows:

01/28/2004 UNDELRI 00000081 10049971

01 FC:1201 1634.00 DP
02 FC:1202 378.00 DP